

# Summary of Plasma-Edge/PMI modeling presentations (Session 3)

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- **Z. Insepov: MD He<sup>+</sup> sputtering on lithium from 50 K to 700 K**
  - Sputtering of He<sup>+</sup> from 10-1000 eV shows BSY model lower bound
  - Temperature enhancement in PISCES, UIUC not in simple model
  - He bubble formation/eruption may explain temp. enhancement; MD sample size must be large enough; surface pre-heating may be key
- **L. Zepeda: MD carbon sputtering and plasma modeling**
  - Amorphous C-H MD samples prepared via melting/quenching
  - ARIEBO/REBO simulations compare well with Mech '98,  $E > 100$  eV; Yield lower than Mech for  $E < 100$  eV; need long-time effects
  - DIII-D edge modeling sensitive to factors  $\sim 2$  variation in C yield
- **T. Evans: Kinetic ion impurity modeling with MCI**
  - Improved mesh for edge region (pedestal, SOL, divertor)
  - Latest Li and Be (for ITER) rates from ADAS - important at low  $T_e$
  - DIII-D edge modeling for DiMES plasma shows strong sensitivity of carbon to background plasma model